

Notice of References Cited	Application/Control No. 10/502,003		Applicant(s)/Patent Under Reexamination READ, DALE	
	Examiner LIN B. OLSEN		Art Unit 3661	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-5,010,634	04-1991	Uemura et al.	29/407.05
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*	E	US-6,157,873	12-2000	DeCamp et al.	700/253
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	V	Krishnamurthy et al. "A Hybrid Manufacturing System Modeling Environment Using VRML", in J.J. Mills & F. Kimura (Eds), Information Infrastructure Systems for Manufacturing, Boston: KluwerAcademic Publishers, 1999.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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